PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q78963

Hirotomo SASAKI, et al.

Appln, No.: 10/743,437 Group Art Unit: 1762

Confirmation No.: 8137 Examiner: James LIN

Filed: December 23, 2003

For: METHOD FOR PRODUCING LIGHT-TRANSMITTING ELECTROMAGNETIC WAVE-SHIELDING FILM, LIGHT-TRANSMITTING ELECTROMAGNETIC WAVE-SHIELDING FILM AND PLASMA DISPLAY PANEL USING THE SHIELDING FILM

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on February 22, 2008:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Office Communication dated February 22, 2008.

During the interview, the following was discussed:

- 1. Brief description of exhibits or demonstration: NA
- 2. Identification of claims discussed: 6 and 12
- 3. Identification of art discussed: Takaoka
- 4. Identification of principal proposed amendments: Applicants proposed an independent claim reciting the subject matter of claim 12, claims reciting preferred Ag/binder volume ratios and a claim reciting the aperture ratio of the wave-shielding film.

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5. Brief Identification of principal arguments: Takaoka discloses a silver salt diffusion

transfer process utilizing physical development nuclei, which is distinguishable from the present

application. The cited art also fails to disclose or suggest the presently recited Ag/binder volume

ratio.

6. Indication of other pertinent matters discussed: Applicants provided a copy of the

European search report for the corresponding European application and noted that Applicants

will follow up with an IDS.

7. Results of Interview: The Examiner indicated he would give favorable consideration

to the proposals Applicants were considering.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF

INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems

otherwise. Applicant hereby petitions for any extension of time which may be required to

maintain the pendency of this case, and any required fee, except for the Issue Fee, for such

extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

Registration No. 61,444

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WASHINGTON OFFICE 23373

Date: March 27, 2008

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